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Attorney Docket SEL 238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of )  
Hiroki et al. )  
Serial No.: 09/776,472 )  
Filed: February 2, 2001 )  
For: Thin Film Formation Apparatus And )  
Method Of Manufacturing Self-Light- )  
Emitting Device Using Thin Film )  
Formation Apparatus )  
Art Unit: 1762 )  
Examiner: M. Cleveland )  
Commissioner for Patents  
Washington, D.C. 20231

I hereby certify that this correspondence is being  
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Rachel Hammerquist  
Name of applicant, assignee, or Registered Rep.

Rachel Hammerquist 12-26-02  
Signature Date

#9/B  
MJA  
1/9/03

AMENDMENT B

Sir:

In response to the Office Action of September 25, 2002, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

6 (Amended). A method of manufacturing a self-light-emitting device, comprising the steps

B1 of:

filling a nozzle with an application liquid for forming an EL layer; and

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